

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 5377

Makiko KITAZOE, et al

Art Unit: 1792

Application No.: 10/591,905

Examiner: Keath T. CHEN

Filed: November 6, 2006

Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS
AND CLEANING METHOD THEREOF

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION (RCE)

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 8, 2009

Sir:

In reply to the July 8, 2009, Office Action, and upon grant of the attached Request for Continued Examination (RCE), please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2; and

Remarks begin on page 7.